



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

1746
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2.3.03

In re Application of:

Donald L. Yates

Serial No.: 10/027,951

Filed: December 19, 2001

For: METHOD OF REDUCING WATER
SPOTTING AND OXIDE GROWTH ON A
SEMICONDUCTOR STRUCTURE

Examiner: ~~Unknown~~ Markoff

Group Art Unit: 1746

Attorney Docket No.: 3375.6US (95-0999.5)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail (under 37 C.F.R. § 1.8(a)) on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

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PRELIMINARY AMENDMENT

Box Non-Fee Amendment
Commissioner for Patents
Washington, D.C. 20231

Sir:

Prior to examination of the above-referenced patent application on the merits, entry of the amendments as set forth herein is respectfully solicited.

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